

HIGH-DENSITY MASK FOR THREE-DIMENSIONAL SUBSTRATES AND METHODS FOR MAKING THE SAME

ABSTRACT

A method for fabricating high-density masks for non-planar or three-dimensional substrates utilizes a mandrel having one or more precision forms machined therein. Once the mandrel with one or more forms is fabricated, one
5 or more mask blanks may be constructed thereon. The final masks may be cut from one or more mask blanks.

Figure 1C